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Bib Data Sheet

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| SERIAL NUMBER 10/754,518 | FILING OR 371(c) DATE 01/12/2004 RULE | CLASS 257 | GROUP ART UNIT 2814 | ATTORNEY DOCKET NO. 60188-751 | |
| APPLICANTS Yoshiharu Hidaka, Osaka, JAPAN; Katsuyuki Ikenouchi, Toyama, JAPAN; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** JAPAN 2003-011017 01/20/2003 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/13/2004 | | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged Examiner's Signature _____ Initials _____ | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 12 | TOTAL CLAIMS 12 | INDEPENDENT CLAIMS 2 |
| ADDRESS 20277 | | | | | |
| TITLE SEMICONDUCTOR SUBSTRATE, METHOD FOR FABRICATING THE SAME, AND METHOD FOR FABRICATING SEMICONDUCTOR DEVICE | | | | | |
| FILING FEE RECEIVED 1070 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |